

Notice of References Cited	Application/Control No. 10/648,340	Applicant(s)/Patent Under Reexamination OGISHIMA ET AL.	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,309,264	05-1994	Lien et al.	349/143
*	B	US-2002/0063834	05-2002	Sawasaki et al.	349/130
*	C	US-2002/0075436	06-2002	Kubo et al.	349/129
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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